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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:

ROGER Y. LEUNG, ET AL.

Docket: H0002489 (4780)

Serial Number: 10/507,410

Group Art Unit: 1762

Filed: September 13, 2004

Examiner: Erma C. Camcron

For: LOW METAL POROUS SILICA DIELECTRIC FOR INTEGRAL CIRCUIT
APPLICATIONS

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed September 13, 2007, please amend the above
identified patent application as follows: